

<b>Notice of References Cited</b>	Application/Control No. 10/816,910	Applicant(s)/Patent Under Reexamination DILL ET AL.	
	Examiner Emeka Ebirim	Art Unit 2166	Page 1 of 1

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*	C	US-2004/0164961 A1	08-2004	Bal et al.	345/163
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	M	US-			

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**NON-PATENT DOCUMENTS**

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\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)  
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